



Docket No.: 50103-368

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

re Application of

David Kuo, et al.

Serial No.: 09/912,065

Group Art Unit: 2652

Filed: July 25, 2001

Examiner: William Klimowicz

For: PATTERNING LONGITUDINAL MAGNETIC RECORDING MEDIA WITH
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RESPONSE TO RESTRICTION

Technology Center 2600

Commissioner for Patents
Washington, DC 20231

Sir:

Noting the restriction imposed by the Office Action mailed March 31, 2003
requiring the election of either:

Group I - claims 1-14, drawn to a method of patterning a magnetic layer; or

Group II - claims 15-18, drawn to a magnetic recording medium;

Applicant elects Group I, method claims 1-14, with traverse.


Applicant respectfully submits that a search of the subject matter of claims 1-14
would likely uncover pertinent art regarding Group II. Accordingly, Applicant
respectfully submits that the burden on the Examiner is not as great in examining both
groups of claims as the burden on applicant in prosecuting two separate applications.
Accordingly, reconsideration and examination of the entire application are respectfully
solicited.

09/912,065

To the extent necessary, a petition for an extension of time under 37 C.F.R. 1.136 is hereby made. Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

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